

46324

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	:	
	:	
<b>Tae-kyoung LEE</b>	:	Group Art Unit: Not Assigned
	:	
Serial No.: To be Assigned	:	Examiner: Not Assigned
	:	
Filed: <b>April 21, 2004</b>	:	
	:	
For: <b>MULTI-BEAM LIGHT SOURCE UNIT</b>	:	
<b>AND LASER SCANNING UNIT</b>	:	
<b>HAVING THE SAME STRUCTURE</b>	:	

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §§ 1.56 and 1.97-1.98, Applicant hereby transmits copies of the documents listed in the attached Form PTO-1449, which may be deemed material to the examination of the above-identified application.

In accordance with the waiver dated July 11, 2003, issued by the U.S. Patent and Trademark Office, copies of U.S. patents and published applications cited herein have been omitted since this application has been filed after June 30, 2003.

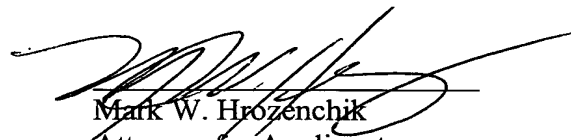
Regarding Japanese Patent Application Publications Nos. P58-086606, P11-242170, 2000-162536, P11-352432A, 2003-075702A, P11-340567A, P10-260369A, and P09-243944A, an English abstract for each is provided as a brief statement of relevance to the above identified application as required under 37 C.F.R. § 1.98. Also, since the present

Information Disclosure Statement is being filed prior to issuance of a first Office Action on the merits, no certification under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(b) is required.

The Examiner is requested to consider the attached documents in connection with the above-identified application and to return a copy of Form PTO-1449 to the Applicant with the Examiner's initials in the spaces provided.

Submission of this Information Disclosure Statement does not constitute an admission by the Applicant as to the materiality of the attached documents to the application, nor does the Applicant waive any right to challenge the validity of the documents as prior art should such action be deemed appropriate.

Respectfully submitted,



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Dated: April 21, 2004

Date  
Considered